

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	46127	plasma adj cvd or plasma adj chemical	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/08 00:43
L2	13416	I1 and glass near4 substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/08 00:45
L3	1145	I2 and silane and halogen and gas	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/08 00:45
L4	877	I3 and carbon	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/08 00:46
L5	115	I4 and (silane near4 gas) and (halogen near4 gas)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2008/03/08 00:47

3/ 8/ 08 1:52:58 AM

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